

Form PTO-1449

ATTY. DOCKET NO.  
2986-122PAPPLICATION NO.  
10/651,040INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

(Use several sheets if necessary)

APPLICANT  
ANZAKI, Toshiaki et al.FILING DATE  
August 29, 2003GROUP  
Unassigned

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	Kind	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	US						
	US						
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## FOREIGN PATENT DOCUMENTS

Office	DOCUMENT NUMBER	Kind	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION	
							YES	NO

## OTHER DOCUMENTS

(Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.)

<i>M. M.</i>	HAYAKAWA Shigeru and WASA Kiyotaka, "Thin-Film Technology", 1 <sup>st</sup> Edition, pages 68-85, Kyoritsu Publishing Co., Ltd., 1982.

EXAMINER

*M. M. Weetstra*

DATE CONSIDERED

*5-2-05*

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 409; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.